



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **IBARA, Yoshikazu et al.**

Group Art Unit: 2823

Serial No.: 09/892,893

Examiner: **COLEMAN, William D.**

Filed: **June 28, 2001**

P.T.O. Confirmation No.: 1585

For. **METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES WITH SILICIDE FILMS THEREON**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: July 25, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated February 25, 2003 for month from May 25, 2003 to July 25, 2003.

Attached please find a check in the amount of \$1,160.00 to cover the cost of a Request for Continued Examination (\$750.00) and the two-month extension (\$410.00) for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

Joseph L. Felber  
Attorney for Applicants  
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Atty. Docket No. **010834**

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PATENT TRADEMARK OFFICE

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Enclosures: Check in amount of \$1,160.00